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EFS ID:

18559

Application ID:

Title of Invention:

10046497\_

Method for Forming Raised

Structures by Controlled Selective

**Epitaxial Growth of Facet Using** 

**Spacer** 

First Named Inventor:

Er-Xuan Ping

Domestic/Foreign Application:

**Domestic Application** 

Filing Date:

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Effective Receipt Date:

Submission Type:

2002-10-03

Information Disclosure Statement

Filing Type:

null

**Confirmation Number:** 

8624

Attorney Docket Number:

MTI-31041-A

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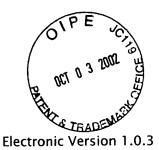
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Page 1 of 1



#### TRANSMITTAL FORM

**Application** 

Number:

10/046,497

**Attorney Docket** 

MTI-31041-

Number:

Α

Stylesheet Version: 1.0

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Disclosure Statement

# Method for Forming Raised Structures by Controlled Selective Epitaxial Growth of Facet Using Spacer

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Attached Files:

us-information-disclosure-statement

MTI31041Aids.xml

Comments:

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# Electronic Information Disclosure **Statement**

Method for Forming Raised Structures y Controlled Seices.

Growth of Facet Using Space of the Controlled Seices. by Controlled Selective Epitaxial

Application:

Confirmation:

8624

Applicant(s):

Er-Xuan Ping

Docket

MTI-31041-A

Number:

Group Art Unit: 2814

Examiner:

search string:

( 5393681 or 6391692 or 5308782 or 5998248 or 6319782 or 4554570 or 5200352 or 5376562 or

5079180 or 5753555 ).pn.

#### **US Patent Documents**

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

llinitl	Citation No.	Patent Number	Date	Bar Code	Patentee	Class	Subclass
	P01	5393681	1995-02-28		Witek et al.	438	164
	P02	6391692	2002-05-21		Nakamura	438	151
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#### Signature

Date		
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